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| APPLICATION NO. FILING DATE |      | ILING DATE   | FIRST NAMED INVENTOR    | ATTORNEY DOCKET NO. | CONFIRMATION NO. |  |
|-----------------------------|------|--------------|-------------------------|---------------------|------------------|--|
| 10/677,610 10/02/2003       |      | 10/02/2003   | Srinivasan Chakravarthi | TI-33161.1          | 8944             |  |
| 23494                       | 7590 | 03/09/2004   | EXAM                    | EXAMINER            |                  |  |
| TEXAS INS<br>P O BOX 65:    |      | ENTS INCORPO | DANG, I                 | DANG, PHUC T        |                  |  |
| DALLAS, T                   | •    |              | ART UNIT                | PAPER NUMBER        |                  |  |
|                             |      |              | 2818                    |                     |                  |  |

DATE MAILED: 03/09/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

|  |   |  |  |   | A          |  |  |  |  |
|--|---|--|--|---|------------|--|--|--|--|
|  |   | Applica  | ation No.  | Applicant(s)  |            |  |  |  |  |
|  |   |  | ,610   | CHAKRAVARTHI ET   | AL.        |  |  |  |  |
|  | Office Action Summary   | Examir   | er   | Art Unit  |            |  |  |  |  |
|  |   |  | Γ DANG   | 2818  |            |  |  |  |  |
| Period fo  | - The MAILING DATE of this communic<br>r Reply  | ation appears on t   | the cover sheet with the d   | correspondence addres   | ss         |  |  |  |  |
| THE M - Exten after S - If the - If NO - Failur Any re | DRTENED STATUTORY PERIOD FOMAILING DATE OF THIS COMMUNIC sions of time may be available under the provisions of SIX (6) MONTHS from the mailing date of this commu period for reply specified above is less than thirty (30) period for reply is specified above, the maximum statue to reply within the set or extended period for reply weply received by the Office later than three months after different adjustment. See 37 CFR 1.704(b). | ATION.  37 CFR 1.136(a). In no nication. days, a reply within the story period will apply and ill. by statute. cause the a | event, however, may a reply be tir<br>statutory minimum of thirty (30) day<br>if will expire SIX (6) MONTHS from<br>application to become ABANDONE | mely filed<br>ys will be considered timely.<br>In the mailing date of this commu<br>ED (35 U.S.C. § 133). | unication. |  |  |  |  |
| Status   |   |  |  |   |            |  |  |  |  |
| 2a) <u></u> □  | Responsive to communication(s) filed This action is <b>FINAL</b> . 2t Since this application is in condition for  | o)⊠ This action is   | s non-final.   | osecution as to the me  | erits is   |  |  |  |  |
|  | closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.   |  |  |   |            |  |  |  |  |
| Dispositi  | on of Claims  |  | •  |   |            |  |  |  |  |
| 5)□<br>6)⊠<br>7)⊠                                      | Claim(s) <u>8-16</u> is/are pending in the ap<br>4a) Of the above claim(s) is/are<br>Claim(s) is/are allowed.<br>Claim(s) <u>8,10,11 and 13-15</u> is/are rejected to<br>Claim(s) <u>9,12 and 16</u> is/are objected to<br>Claim(s) are subject to restriction  | e withdrawn from ected.  |  |   |            |  |  |  |  |
| Application  | on Papers   |  |  |   |            |  |  |  |  |
| 10)⊠   | The specification is objected to by the The drawing(s) filed on <u>12 December</u> Applicant may not request that any object Replacement drawing sheet(s) including t The oath or declaration is objected to  | 2003 is/are: a)⊠<br>ion to the drawing(s<br>he correction is req   | s) be held in abeyance. Se<br>uired if the drawing(s) is ob  | ee 37 CFR 1.85(a).<br>pjected to. See 37 CFR 1  | 1.121(d).  |  |  |  |  |
| Priority u   | nder 35 U.S.C. § 119  |  |  |   | •          |  |  |  |  |
| a)[  | Acknowledgment is made of a claim for All b) Some * c) None of:  1. Certified copies of the priority of the priority of the certified copies of the priority of the certified copies of the certified copies of application from the Internation see the attached detailed Office action  | ocuments have b<br>ocuments have b<br>f the priority docu<br>al Bureau (PCT F  | een received.<br>een received in Applicat<br>ments have been receiv<br>Rule 17.2(a)).  | ion No<br>ed in this National Sta   | nge        |  |  |  |  |
| 2) Notice 3) Inform                                    | e of References Cited (PTO-892)<br>e of Draftsperson's Patent Drawing Review (PT<br>nation Disclosure Statement(s) (PTO-1449 or P<br>r No(s)/Mail Date <u>1003</u> .  |  | 4) Interview Summary Paper No(s)/Mail D 5) Notice of Informal I 6) Other:  |   | 2)         |  |  |  |  |

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#### **DETAILED ACTION**

1. This application is a divisional of 10/020,813 filed on December 12, 2001.

## **Preliminary Amendment**

2. In Preliminary Amendment filed on October 2, 2003, Applicants cancel claims 1-7 and 17-

21 and claims 8-16 are still pending in the application.

### Oath/Declaration

3. The oath/declaration filed on October 2, 2003 is acceptable.

## **Information Disclosure Statement**

4. The office acknowledges receipt of the following items from the applicant:

Information Disclosure Statement (IDS) filed on October 2, 2003.

#### **Drawings**

5. The formal drawings filed on December 12, 2003 have been acknowledged.

#### **Specification**

6. The specification has been checked to the extent necessary to determine the presence of all possible minor errors. However, the applicant's cooperation is requested in correcting any errors of which applicant may become aware in the specification.

## Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary

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skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

7. Claims 8, 10-11 and 13-15 are rejected under 35 U.S.C. 103(a) as being unpatentable over Kimura (U.S. Patent No. 5,602,045) in view of Bensahel et al. (U.S. Patent No. 4,263,056).

Kimura discloses a method of doping a single crystal semiconductor substrate, comprising:

exposing a surface of the substrate to high energy particles to pre-amorphize a layer of
the crystal adjacent the substrate; and

implanting the substrate with a temporary impurity atom;

heating the substrate to cause the crystal to re-grow within the layer adjacent the surface [col. 6, lines 43-59].

Kimura discloses all the features of the claimed invention as discussed above, but does not disclose the steps of forming a coating comprising a target dopant over the surface of the substrate either before, during, or after heating; and annealing to cause the target dopant to diffuse from the coating into the substrate.

Bensahel et al., however, disclose the steps of forming a coating comprising a target dopant over the surface of the substrate either before, during, or after heating; and annealing to cause the target dopant to diffuse from the coating into the substrate [col. 4, lines 49-54].

It would have been obvious to one having ordinary skilled in the art at the time the invention was made to apply the teaching of Bensahel et al. to Kimura discussed above such that the steps of forming a coating comprising a target dopant over the surface of the substrate either before, during, or after heating; and annealing to cause the target dopant to diffuse from the

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coating into the substrate for a purpose of improving the process of doping a single crystal semiconductor substrate.

Regarding claims 10-11, Kimura discloses the high energy particles comprise particles selected from the group consisting of Ge, In, Sb, Si and Ar and the temporary impurity atom is implanted with a dose of at least about 1x10 <sup>14</sup> atoms/cm<sup>2</sup> [col. 4, lines 36-39].

Regarding claims 13-15, Bensahel et al. disclose the chemical material, the location and the concentration of the target dopant used in the process of doping a single crystal semiconductor substrate [col. 3, lines 50-58].

It would have been obvious to one having ordinary skilled in the art at the time the invention was made to apply the teaching of Bensahel et al. to Kimura discussed above such that for a purpose of improving the process of doping a single crystal semiconductor substrate.

## Allowable Subject Matter

8. Claims 9, 12 and 16 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

#### Conclusion

- 9. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Phuc T. Dang whose telephone number is (571) 272-1776. The examiner can normally be reached on 8:00 am-5:00 pm.
- 10. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David C. Nelms can be reached on (571) 272-1787. The fax phone numbers for the organization

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where this application or proceeding is assigned are 703-308-7722 for regular communications and 703-872-9306 for After Final communications.

11. Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-0956.

Langphur

Phuc T. Dang

Primary Examiner

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February 26, 2004